

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

M. OGINO, et al.

Application No.:

10/830,051

Filed:

April 23, 2004

For:

WIRING TAPE FOR A SEMICONDUCTOR DEVICE

INCLUDING A BUFFER LAYER HAVING

INTERCONNECTED FOAMS

Art Unit in Parent:

2814

Examiner in Parent:

H. Weiss

<u>AMENDMENT</u>

MS: AMENDMENTS
Commissioner for Patent
P.O. Box 1450
Alexandria, VA 22313-1450

September 16, 2005

Sir:

In response to the Office Action dated May 16, 2005, the period of response for which extension of time is requested in the attached Petition for Extension of Time, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are following the amendments.